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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.

SERIAL NUMBER: 10/030,123

GROUP: 2826

FILED: May 16, 2002

EXAMINER: FORDE, REMMON R

FOR: DEVICE USED TO PRODUCE OR EXAMINE SEMICONDUCTORS

**REQUEST TO CORRECT TITLE OF INVENTION**

MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request correction of your records to reflect the correct title of the invention. The title of the invention should read as follows: **DEVICE USED TO PRODUCE OR EXAMINE SEMICONDUCTORS.**

Respectfully Submitted,

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